Electronic Acknowledgement Receipt				
EFS ID:	3410393			
Application Number:	10812354			
International Application Number:				
Confirmation Number:	4104			
Title of Invention:	Method of improving the wafer to wafer uniformity and defectivity of a deposited dielectric film			
First Named Inventor/Applicant Name:	Noriaki Fukiage			
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Filer Authorized By:	Joseph R. Jordan			
Attorney Docket Number:	071469-0308969 (FKL-020)			
Receipt Date:	05-JUN-2008			
Filing Date:	30-MAR-2004			
Time Stamp:	16:00:46			
Application Type:	Utility under 35 USC 111(a)			

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)			
1		FKL-020_Amendment.pdf	55339	yes	11			
			af70b201ac56a20d2cf3832709cd5f935 a0b80b2					
	Multipart Description/PDF files in .zip description							
	Document Description		Start	End				
	Preliminary Am	1	1					
	Claims		2	7				
	Applicant Arguments/Remarks Made in an Amendment		8	11				
Warnings:								
Information:								
	Request for Continued Examination	FKL-020_RCE.pdf	717670	no	3			
	(RCE)		71124b1cf4f43be10fb1e1511c5e744d6 a840676					
Warnings:								
Information:								
3 Fee Worksheet (Fee Worksheet (PTO-06)	fee-info.pdf	8365	no	2			
	r ee worksneet (r 10-00)		d7ab221b278f6f0cc7f9e11990cc63a9fd c099df	110				
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